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Attorney's Docket No. 740107-135

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of) **RESPONSE UNDER 37 CFR**
Nobuo SHIMAZU et al.) **1.116 – EXPEDITED**
Application No. 09/732,927) **PROCEDURE EXAMING**
Filed: December 11, 2000) **GROUP 2881**
For: MANUFACTURING METHOD OF)
MASK FOR ELECTRON BEAN)
PROXIMITY EXPOSURE AND MASK)
Examiner: T. NGUYEN

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at (703) 872-9319, on May 23, 2003.

April Campbell
April Campbell

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are presented in response to the Examiner's final Office Action mailed February 10, 2003, in connection with the above-identified application.